



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2812

Examiner: Olivia T. Luk

In re PATENT APPLICATION of

Applicant(s) : Eiji TAKAARA

Appln. No. : 10/628,381

Filed : July 29, 2003

For : METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE USING
FLEXIBLE TUBE

Atty. Dkt. : OKI 365

)
)
) **RESPONSE TO**
) **RESTRICTION**
) **REQUIREMENT**
) **AND**
) **AMENDMENT**
)
)
)
)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Restriction Requirement dated December 21, 2004,
applicant elects Invention I, i.e., the subject matter of claims 1 - 14, for further
examination. The election is with traverse.

FEE ENCLOSED: \$6-
Please charge any further
fee to our Deposit Account
No. 18-0002